

Notice of References Cited

Application/Control No.

10/549,444

Applicant(s)/Patent Under
Reexamination
SION ET AL.

Examiner

DAVID TUROCY

Art Unit

1792

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,210,745	04-2001	Gaughan et al.	427/8
*	B	US-6,001,419	12-1999	Leluan et al.	427/249.2
	C	US-			
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	F	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Glasier et al. Formation of pyrolytic carbon during the pyrolysis of ethane at high conversions. Carbon 39 (2001) 15-23.
*	V	Birakayala et al. A reduced reaction model for carbon CVD/CVI processes. Carbon 40 (2002) 675-683.
	W	Chemical Vapor Infiltration, http://en.wikipedia.org/wiki/Chemical_vapor_infiltration
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.